JC17 Rec'd PCT/PTO 16 SEP 2005

SHEET 1 OF 1

INFORMATION DISCLOSURE CITATION IN AN APPLICATION					ATTY. DOCKET NO. 071971-0361		SERIAL NO. Not yet assigned 10/549291			
					APPLICANT Junko IWANAGA, et al.					
(PTO-1449)					FILING DATE September 16, 2005	GROUP Not yet assigned 2815			ed	
			U	.S. PATEN	F DOCUMENTS					
EXAMINER'S INITIALS	CITE NO.	Nur	Occument Number nber-Kind Codes & Anoma)	Publication Date MM-DD-YYYY	Name of Patentee or Appli Occurrent	cant of Cited		Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
731.7		US	4,996,574	2-26-1991	Shirasaki					
1		υs	2002/003256 A1	1-10-2002	Maegawa					
\/		υs	6,288,431 B1	9-11-2001	lwasa					
V		US	6,413,802 B1	7-2-2002	Hu et al					
		US								
		ÜS								
		US								
		US								
		US								
		US								
		US					ļ			
		US					+			
		03		FOREIGN PA	TENT DOCUMENTS					
EXAMINER'S Foreign Patent Document Publication Date					Name of Patentee or	Pages, Colu		Tr	anslation	
INITIALS	CITE NO.	Country Codes -Number 4 -Nnd Codes (If known)		MM-DD-YYYY	Applicant of Cited Document	Where Relevant Figures Appear		Yes	No	
/JL/			EP 0 623 963	11-9-1994	SIEMENS AG		<u> </u>	<u> </u>		
		├						 	 	
		 								
			·						<u> </u>	
			OTHER A	RT (Including Author	or, Title, Date, Pertinent Pages, E	(C.)	the Hem the	ok mana-in	<u>. 1</u>	
EXAMINER'S INITIALS	CITE NO.	journ	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.							
/JL/	/JL/ KEDZIERSKI et al., "High-Performance Symmetric-Gate and CMOS-Compatible Vt Asymmetric-Gate FinFET Devices", International Electron Devices Meeting 2001, IEDM Technical Digest. Washington DC, Dec. 2-5, 2001, New York, NY: IEEE, pp1951-1954, XP010575161									
		<u> </u>							-	
EXAMINER DATE CONSIDERED /John Lin/ 06/20/2007										

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.